



IPW

Docket No.: SON-2413/DIV
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Shigeru Moriya, et al.

Application No.: 10/689,098

Art Unit: 1756

Filed: October 21, 2003

Conf. No. 3815

For: MASK, METHOD OF PRODUCING MASK,
AND METHOD OF PRODUCING
SEMICONDUCTOR DEVICE

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please inform the undersigned when the initial Action on the merits of the above-identified application may be expected. The application has now been approximately one year without an action on the merits.

Respectfully submitted,

Dated: October 25, 2004

Ronald P. Kananen
Reg. No. 24,104

RADER, FISHMAN & GRAUER P.L.L.C.
1233 20TH Street, NW
Suite 501
Washington, DC 20036
202-955-3750-Phone
202-955-3751 - Fax
Customer No. 23353